

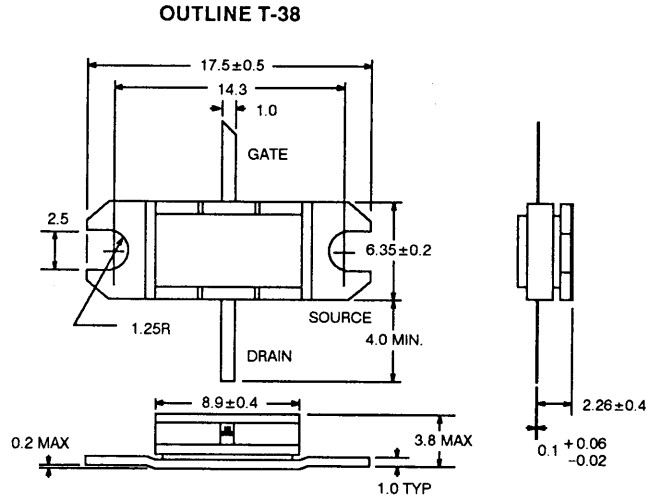
### FEATURES

- CLASS A OPERATION
- HIGH POWER OUTPUT
- HIGH GAIN
- HIGH POWER ADDED EFFICIENCY
- HIGH RELIABILITY
- AVAILABILITY: Hermetic Package

### DESCRIPTION

The NE1069L-4B is an unmatched N-channel power GaAs MESFET which offers high output power, high gain and high efficiency in L to S-band. The device incorporates Ti-Au metallization and silicon dioxide glassivation. The WSi (Tungsten silicide) gate is incorporated for high reliability. The gate length is 0.8  $\mu\text{m}$  for increased linear gain. To reduce thermal resistance, the devices have a PHS (Plated Heat Sink). NEC's stringent quality assurance and test procedures assure the highest reliability and performance.

### OUTLINE DIMENSIONS (Units in mm)



Flange Material: Copper  
Flange Plating: Ni, Au

Lead Material: Kovar  
Lead Plating: Ni, Au

### ELECTRICAL CHARACTERISTICS ( $T_A = 25^\circ\text{C}$ )

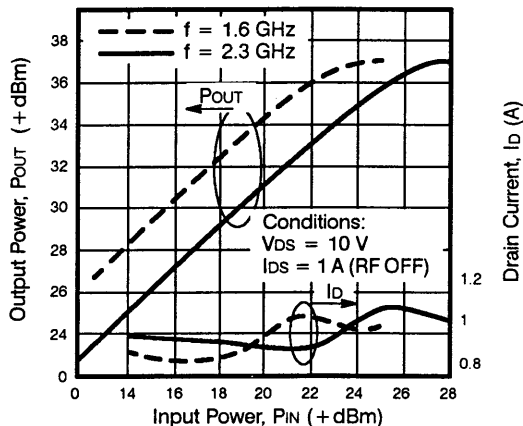
PART NUMBER			NE1069L-4B		
SYMBOLS	PARAMETERS AND CONDITIONS	UNITS	MIN	TYP	MAX
$I_{DSS}$	Saturated Drain Current, $V_{DS} = 2.5$ V, $V_{GS} = 0$	A	2.2	2.7	3.5
$V_P$	Pinch-off Voltage, $V_{DS} = 2.5$ V, $I_D = 14$ mA	V	-5	-3.5	-2
$g_m$	Transconductance, $V_{DS} = 2.5$ V, $I_D = 10$ A	mS		1000	
$R_{TH}$	Thermal Resistance (channel to case, $T_{CH} = 125^\circ\text{C}$ )	$^\circ\text{C/W}$		5	6
$P_{1dB}$	Output Power at 1 dB G.C.P.	dBm	35.5	36.5	
$G_L$	Linear Power Gain				
$I_D$	Drain Current	A		1.1	1.4
$I_G$	Gate Current				
$\eta_{ADD}$	Power Added Efficiency	%		40	
$P_{OUT}$	Output Power, $P_{IN} = 27$ dBm	dBm		37	
$P_{1dB}$	Output Power at 1 dB G.C.P.				
$G_L$	Linear Gain	dB		14.5	

$V_{DS} = 10$  V,  $f = 2.3$  GHz  
 $I_{DS} = 1$  A (RF OFF)

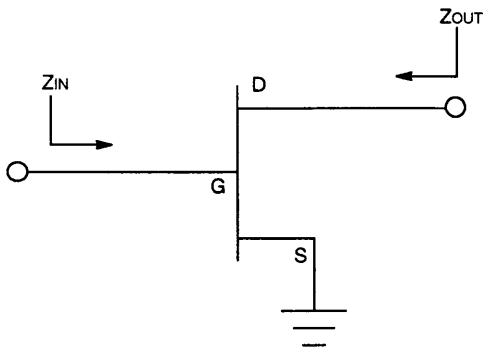
$V_{DS} = 10$  V,  $f = 1.6$  GHz,  
 $I_{DS} = 1$  A (RF OFF)

**TYPICAL PERFORMANCE CHARACTERISTICS** ( $T_A = 25^\circ\text{C}$ )

**OUTPUT POWER AND DRAIN CURRENT vs. INPUT POWER**



**INPUT AND OUTPUT DYNAMIC IMPEDANCE**



PART NUMBER	f = 1.6 GHz		f = 2.3 GHz	
	Z <sub>IN</sub> (Ω)	Z <sub>OUT</sub> (Ω)	Z <sub>IN</sub> (Ω)	Z <sub>OUT</sub> (Ω)
NE1069L-4B	3.1 + j2.0	10.7 + j3.2	3.5 + j4.7	6.7 + j6.2

**MAXIMUM OPERATING LIMITS**

PART NUMBER	R <sub>G</sub> MAX	I <sub>G</sub> RF MAX	V <sub>ds</sub> MAX
	Ω	mA	V
NE1069L-4B	100	10	10.0

R<sub>G</sub> MAX is the maximum series resistance between the gate supply and the FET gate.





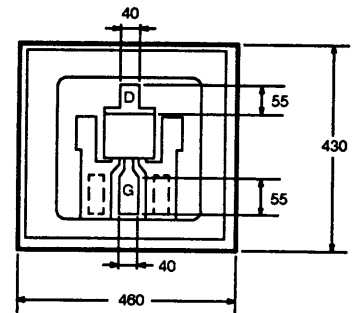
- Medium Power FETs

### FEATURES

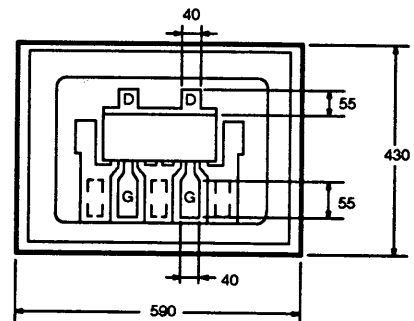
- CLASS A OPERATION
- HIGH OUTPUT POWER
- HIGH LINEAR GAIN
- HIGH POWER ADDED EFFICIENCY
- HIGH RELIABILITY

### OUTLINE DIMENSIONS (Units in $\mu\text{m}$ )

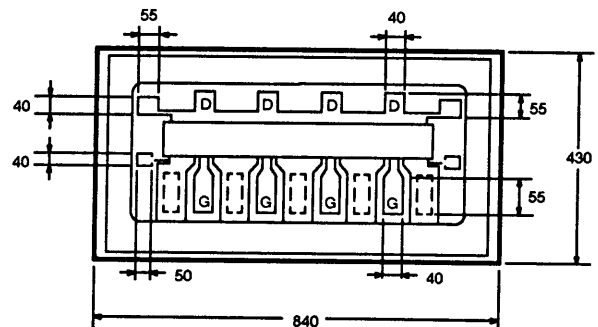
NE985100 (CHIP)



NE985200 (CHIP)



NE985400 (CHIP)



D: Drain contact pad  
 G: Gate contact pad  
 □: Via-hole

### DESCRIPTION

The NE985 power GaAs FET series offers high output power and high gain in K-band. The device has a gate length of  $0.3\ \mu\text{m}$  to increase linear gain and employs PHS (Plated Heat Sink) technology to reduce the thermal resistance.

The NE985100 consists of 1 cell, the NE985200 consists of 2 cells and the NE985400 consists of 4 cells.

### SELECTION CHART

P <sub>1</sub> dB	PART NUMBER
20 dBm	NE985100
23 dBm	NE985200
26 dBm	NE985400

**ABSOLUTE MAXIMUM RATINGS** (TA = 25°C)

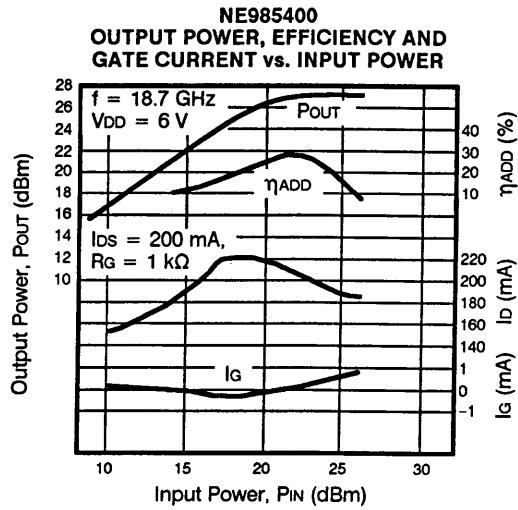
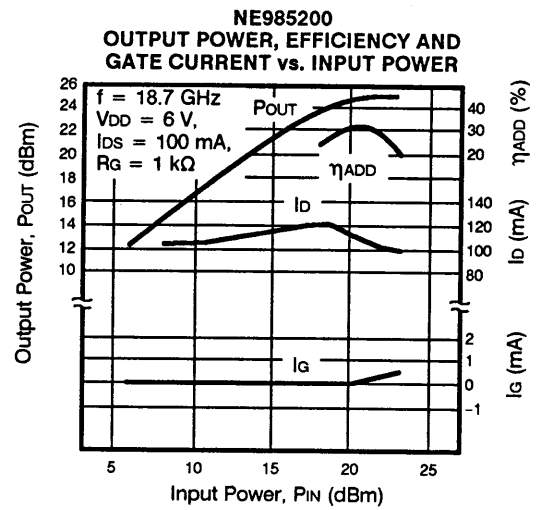
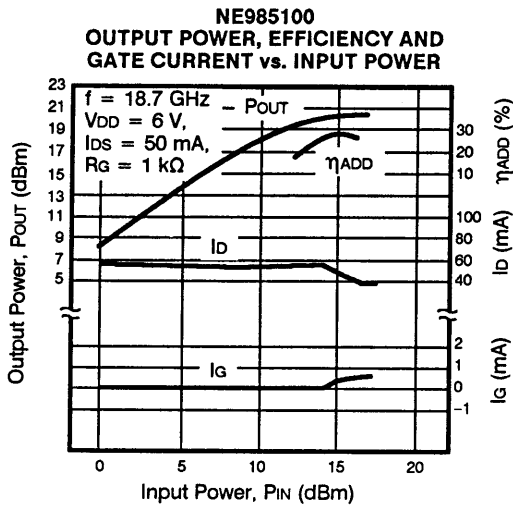
SYMBOLS	PARAMETERS	UNITS	RATINGS
Vds	Drain to Source Voltage	V	8
Vgd	Gate to Drain Voltage	V	-13
Vgs	Gate to Source Voltage	V	-5
Id	Drain Current, NE985100 NE985200 NE985400	A	0.15
		A	0.3
		A	0.6
Ig	Gate Current, NE985100 NE985200 NE985400	mA	1
		mA	2
		mA	4
P <sub>T</sub>	Total Power Dissipation NE985100 NE985200 NE985400	W	2
		W	3
		W	5
T <sub>CH</sub>	Channel Temperature	°C	175
T <sub>STG</sub>	Storage Temperature	°C	-65 to +175

**ELECTRICAL CHARACTERISTICS** (TA = 25°C)

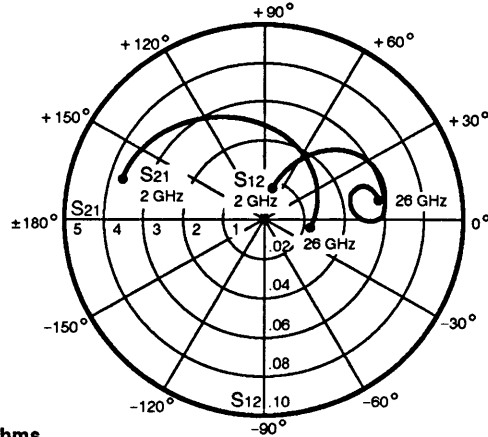
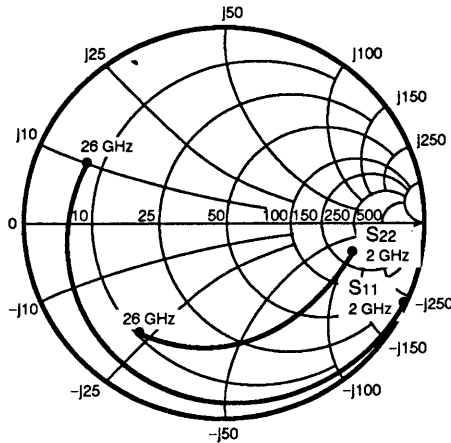
PART NUMBER PACKAGE OUTLINE			NE985100 00(CHIP)			NE985200 00(CHIP)			NE985400 00(CHIP)		
SYMBOLS	PARAMETERS AND CONDITIONS	UNITS	MIN	TYP	MAX	MIN	TYP	MAX	MIN	TYP	MAX
I <sub>DSS</sub>	Drain Current at V <sub>DS</sub> = 2.5 V, V <sub>GS</sub> = 0	mA	60	100	150	120	200	300	240	400	600
V <sub>P</sub>	Pinch-Off Voltage at V <sub>DS</sub> = 2.5 V, I <sub>D</sub> = 0.5 mA I <sub>D</sub> = 1 mA I <sub>D</sub> = 2 mA	V	-4	-2.5	-1						
		V				-4	-2.5	-1			
		V							-4	-2.5	-1
g <sub>m</sub>	Transconductance at V <sub>DS</sub> = 2.5 V, I <sub>D</sub> = 50 mA I <sub>D</sub> = 100 mA I <sub>D</sub> = 200 mA	mS		50							
		mS					100				
		mS								200	
R <sub>TH</sub> (C-C)	Thermal Resistance at T <sub>CH</sub> = 125°C	°C/W		40	70		30	50		18	30
P <sub>1dB</sub>	Output Power at 1 dB Compression Point V <sub>DS</sub> = 6 V, f = 18.7 GHz, I <sub>D</sub> = 0.5 I <sub>DSS</sub> (RF OFF)	dBm	19	20		22	23		25	26	
GL	Linear Power Gain V <sub>DS</sub> = 6 V, f = 18.7 GHz, I <sub>D</sub> = 0.5 I <sub>DSS</sub> (RF OFF)	dB	6.5	7.5		6	7		5	6	
I <sub>DS</sub>	Drain Current V <sub>DS</sub> = 6 V, f = 18.7 GHz, I <sub>D</sub> = 0.5 I <sub>DSS</sub> (RF OFF)	mA		60	75		120	150		240	300
η <sub>ADD</sub>	Power Added Efficiency V <sub>DS</sub> = 6 V, f = 18.7 GHz, I <sub>D</sub> = 0.5 I <sub>DSS</sub> (RF OFF)	%		25			25			22	
P <sub>OUT</sub>	Output Power at V <sub>DS</sub> = 6 V, f = 18.7 GHz, I <sub>D</sub> = 0.5 I <sub>DSS</sub> (RF OFF), P <sub>IN</sub> = 16 dBm P <sub>IN</sub> = 19 dBm P <sub>IN</sub> = 23 dBm	dBm dBm dBm		21			24			27	

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TYPICAL PERFORMANCE CHARACTERISTICS ( $T_A = 25^\circ\text{C}$ )



TYPICAL COMMON SOURCE SCATTERING PARAMETERS



**NE985100**  
Coordinates in Ohms  
Frequency in GHz  
(V<sub>DS</sub> = 6 V, I<sub>DS</sub> = 50 mA)

Note: S-Parameters include bond wires.

- Gate: Total 1 wire (s), 1 per bond pad, 0.0101" (256 μm) long each wire.
- Drain: Total 1 wire (s), 1 per bond pad, 0.0098" (248 μm) long each wire.
- Source: No bond wires. Via holes to back side of chip.
- Wire: 0.0007" (17.7 μm) diameter, gold.

**S-MAGN AND PHASE:**  
V<sub>DS</sub> = 6 V, I<sub>DS</sub> = 50 mA

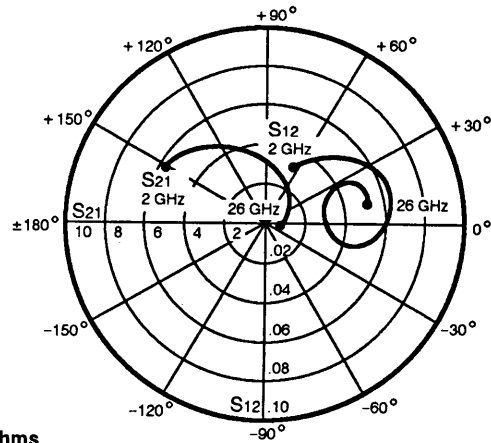
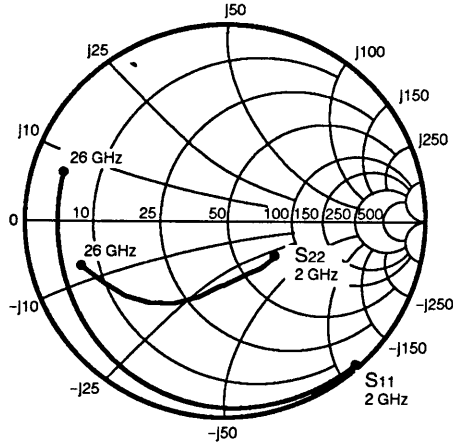
FREQUENCY (MHz)	S <sub>11</sub>	S <sub>21</sub>	S <sub>12</sub>	S <sub>22</sub>	K	G <sub>ma</sub> (dB)				
2000	.99	-30	3.65	157	.021	72	.65	-14	.04	22.4
3000	.98	-45	3.51	146	.031	64	.64	-21	.11	20.6
4000	.96	-58	3.34	135	.038	55	.63	-27	.20	19.5
5000	.94	-69	3.13	126	.042	50	.62	-33	.27	18.7
6000	.92	-80	2.85	116	.048	45	.62	-33	.33	17.9
7000	.90	-90	2.77	108	.049	39	.61	-43	.42	17.5
8000	.89	-98	2.64	100	.051	38	.61	-47	.43	17.1
9000	.88	-108	2.52	92	.060	33	.62	-54	.37	16.2
10000	.87	-117	2.38	84	.061	26	.61	-58	.48	15.9
11000	.85	-124	2.27	77	.059	24	.61	-63	.54	15.8
12000	.85	-132	2.16	70	.064	21	.61	-68	.58	15.3
13000	.84	-138	2.06	64	.063	14	.61	-72	.63	15.2
14000	.83	-145	1.94	58	.061	10	.61	-77	.70	15.0
15000	.82	-151	1.86	52	.061	6	.62	-81	.76	14.9
16000	.82	-157	1.75	45	.058	4	.63	-85	.85	14.8
17000	.80	-160	1.68	40	.055	-0	.64	-89	1.04	13.6
18000	.79	-164	1.57	35	.053	-1	.64	-92	1.18	12.2
19000	.79	-168	1.53	30	.046	0	.64	-96	1.41	11.4
20000	.78	-172	1.46	26	.042	10	.66	-99	1.50	11.2
21000	.78	-176	1.42	20	.046	15	.67	-104	1.29	11.6
22000	.78	180	1.37	15	.053	23	.69	-109	1.04	13.0
23000	.78	174	1.31	8	.062	18	.69	-114	.87	13.2
24000	.77	169	1.24	4	.059	15	.69	-119	1.07	11.6
25000	.76	163	1.18	-2	.058	15	.69	-123	1.15	10.7
26000	.76	158	1.17	-6	.059	14	.70	-127	1.14	10.7





# NE985 SERIES

## TYPICAL COMMON SOURCE SCATTERING PARAMETERS



**NE985200**  
Coordinates in Ohms  
Frequency in GHz  
(V<sub>DS</sub> = 6 V, I<sub>DS</sub> = 100 mA)

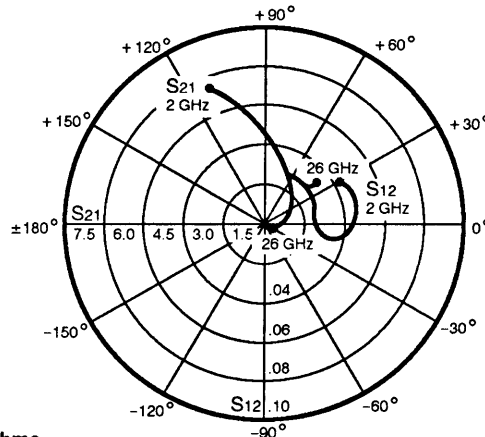
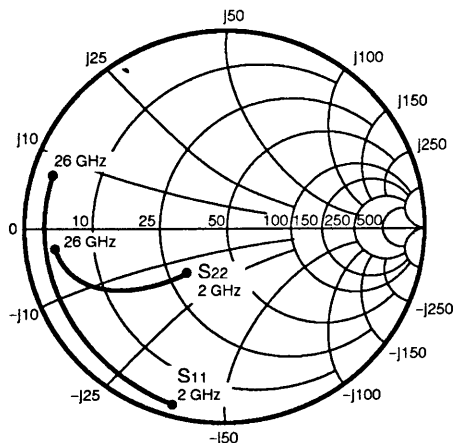
**Note:** S-Parameters include bond wires.

- Gate: Total 2 wire (s), 1 per bond pad, 0.0098" (248 μm) long each wire.
- Drain: Total 2 wire (s), 1 per bond pad, 0.0103" (261 μm) long each wire.
- Source: No bond wires. Via holes to back side of chip.
- Wire: 0.0007" (17.7 μm) diameter, gold.

### S-MAGN AND PHASE: V<sub>DS</sub> = 6 V, I<sub>DS</sub> = 100 mA

FREQUENCY (MHz)	S <sub>11</sub>		S <sub>21</sub>		S <sub>12</sub>		S <sub>22</sub>		K	G <sub>ma</sub> (dB)
2000	.97	-59	5.26	140	.038	56	.30	-47	.07	21.4
3000	.94	-82	4.58	124	.049	43	.31	-65	.13	19.7
4000	.92	-99	3.95	111	.054	34	.31	-78	.23	18.6
5000	.90	-112	3.43	100	.057	28	.33	-87	.31	17.8
6000	.88	-123	2.99	91	.061	22	.35	-95	.35	16.9
7000	.88	-131	2.64	83	.060	17	.37	-101	.44	16.5
8000	.88	-137	2.39	76	.062	16	.40	-106	.40	15.9
9000	.87	-143	2.17	68	.066	9	.43	-112	.41	15.1
10000	.87	-149	1.95	62	.063	4	.45	-116	.52	14.9
11000	.87	-153	1.80	56	.059	2	.48	-119	.59	14.9
12000	.87	-157	1.67	50	.059	-2	.50	-123	.58	14.5
13000	.87	-161	1.56	45	.057	-5	.53	-126	.65	14.4
14000	.86	-165	1.45	39	.056	-9	.55	-129	.74	14.1
15000	.86	-169	1.35	33	.051	-13	.57	-132	.92	14.3
16000	.86	-172	1.26	28	.048	-13	.58	-135	1.08	12.5
17000	.85	-174	1.18	24	.040	-13	.60	-137	1.52	10.4
18000	.84	-176	1.10	21	.040	-8	.62	-140	1.60	9.8
19000	.84	-178	1.04	16	.030	-6	.63	-143	2.43	8.7
20000	.85	180	0.98	14	.030	13	.66	-144	2.16	9.0
21000	.86	179	0.95	10	.036	23	.68	-147	1.57	9.8
22000	.84	176	0.89	7	.046	25	.70	-149	1.25	9.9
23000	.83	173	0.84	1	.051	17	.71	-152	1.24	9.2
24000	.82	170	0.79	-1	.045	14	.71	-155	1.71	7.6
25000	.84	168	0.76	-4	.050	14	.72	-158	1.34	8.3
26000	.85	165	0.75	-8	.054	12	.73	-160	1.08	9.7

TYPICAL COMMON SOURCE SCATTERING PARAMETERS



**NE985400**  
Coordinates in Ohms  
Frequency in GHz  
(V<sub>DS</sub> = 6 V, I<sub>DS</sub> = 200 mA)

**Note:** S-Parameters include bond wires.

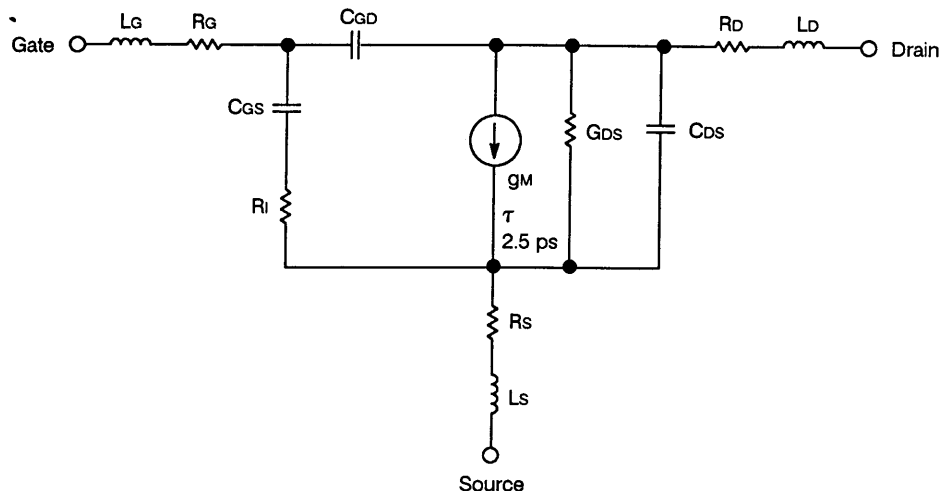
- Gate: Total 4 wire (s), 1 per bond pad, 0.0122" (309 μm) long each wire.
- Drain: Total 4 wire (s), 1 per bond pad, 0.0118" (300 μm) long each wire.
- Source: No bond wires. Via holes to back side of chip.
- Wire: 0.0007" (17.7 μm) diameter, gold.

**S-MAGN AND PHASE:**  
V<sub>DS</sub> = 6 V, I<sub>D</sub> = 200 mA

FREQUENCY (MHz)	S <sub>11</sub>	S <sub>21</sub>	S <sub>12</sub>	S <sub>22</sub>	K	G <sub>ma</sub> (dB)				
2000	.93	-107	5.49	113	.042	30	.31	-131	.10	21.2
3000	.91	-128	4.05	97	.044	20	.36	-137	.20	19.6
4000	.90	-140	3.16	86	.044	15	.39	-139	.34	18.6
5000	.89	-149	2.57	76	.044	13	.43	-140	.45	17.7
6000	.89	-154	2.14	69	.047	8	.46	-141	.46	16.6
7000	.90	-158	1.84	62	.044	4	.50	-142	.52	16.2
8000	.90	-162	1.62	56	.044	6	.54	-143	.51	15.6
9000	.90	-166	1.43	48	.045	-4	.57	-146	.56	15.0
10000	.90	-169	1.25	43	.040	-6	.60	-147	.71	14.9
11000	.90	-171	1.12	38	.036	-6	.63	-149	.85	14.9
12000	.91	-172	1.02	32	.035	-8	.66	-150	.76	14.6
13000	.91	-174	0.93	27	.033	-10	.69	-152	.88	14.5
14000	.91	-176	0.86	22	.029	-16	.71	-154	1.11	12.7
15000	.91	-178	0.78	17	.027	-16	.73	-156	1.38	11.0
16000	.91	180	0.72	13	.027	-5	.74	-157	1.45	10.3
17000	.90	178	0.66	9	.028	8	.76	-158	1.63	9.1
18000	.89	177	0.62	7	.027	16	.77	-159	1.75	8.6
19000	.89	175	0.58	2	.029	47	.79	-160	1.79	7.8
20000	.90	174	0.54	3	.028	64	.80	-160	1.80	7.6
21000	.90	172	0.52	-1	.027	66	.82	-161	1.84	7.5
22000	.90	170	0.49	-3	.027	50	.82	-163	1.76	7.5
23000	.90	168	0.45	-7	.027	33	.83	-166	1.69	7.4
24000	.90	167	0.43	-9	.030	39	.83	-168	1.53	7.3
25000	.90	166	0.41	-10	.033	39	.84	-171	1.41	7.2
26000	.90	165	0.40	-15	.033	38	.85	-172	1.38	7.2

# NE985 SERIES

## EQUIVALENT CIRCUIT



**Note:** Inductance of bonding wire is included.

20  $\mu\text{m}$   $\phi$  Au wire

Gate: Total 2 wires, 1 per bond pad, 0.013" Long each wire.

Drain: Total 2 wires, 1 per bond pad, 0.015" Long each wire.

Source: VIA HOLE INDUCTOR.

ELEMENT	PART NUMBER			UNIT
	NE985100	NE985200	NE985400	
L <sub>G</sub>	0.15	0.11	0.08	nH
R <sub>G</sub>	1.2	0.52	0.24	Ohm
C <sub>Gs</sub>	0.43	0.83	1.74	pF
R <sub>i</sub>	0.46	0.22	0.16	Ohm
R <sub>s</sub>	1.42	1.06	0.58	Ohm
L <sub>s</sub>	0.00814	0.00338	0.00176	nH
g <sub>M</sub>	43.6	84.3	181	mS
g <sub>D</sub>	3.85	8.06	16.1	mS
C <sub>Gd</sub>	0.017	0.031	0.074	pF
C <sub>Ds</sub>	0.176	0.285	0.513	pF
R <sub>D</sub>	5.86	3.10	1.08	Ohm
L <sub>D</sub>	0.150	0.120	0.104	nH

## CHIP HANDLING

### DIE ATTACHMENT

Die attach operation can be accomplished with AuSn preforms, within 10 seconds at  $320 \pm 5^\circ\text{C}$ , in a forming gas environment.

The flow quantity: 300 liter/hour

Gas Contents: N<sub>2</sub>

Recommended solder size:

0.33□, t = 30 μm 1 pc for NE985100 and NE985200

0.33□, t = 30 μm 2 pcs for NE985400

Recommended mounting base material: Cu, CuW, KV

Epoxy die attach is not allowed.

### BONDING

Bond wire should be semi soft gold wire (8% to elongation) 20 microns in diameter, with length kept to a minimum. Bonding should be performed with a wedge tip that has a taper of approximately 15%. Bonding time should be kept to a minimum.

As a general rule, the bonding operation should be kept within a  $260 \pm 10^\circ\text{C}$ , 2 minutes for all bonding wires. The operation should be performed in a forming gas environment. If longer periods are required, the temperature should be lowered.

The flow quantity: 100 liter/hour

Gas Contents: N<sub>2</sub>

Bonding force: 21 ±2 g

Thermal compress bonding is recommended.

### PRECAUTIONS

The user must operate in a clean, dry environment. The chip active area is glassivated for mechanical protection only and does not preclude the necessity of a clean environment.

The bonding equipment should be periodically checked for sources of surge voltage and should be properly grounded at all times. In fact, all test and handling equipment should be grounded to minimize the possibilities of static discharge.